



The University of Michigan Radiation Laboratory
3228 EECS Building
Ann Arbor, Michigan 48109-2122 USA
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Fax: (734) 647-2106
e-mail: liepa@umich.edu

Attn.: Certification and Engineering Bureau, Industry Canada
3701 Carling Avenue, Bldg. 94
Ottawa, Ontario K2H 8S2
Re: Certification for Continental Automotive Systems US Inc. M3N-97395900
IC: 7812A-97395900

Please find enclosed application materials for certification of Continental Automotive Systems US Inc. M3N-97395900. We tested it and found it to comply with IC RSS-210/GENe.

Current Variants:

There are ten (10) variants of the EUT as described in the Description of Variants exhibit included with this filing. All variants employ the same PCB, but vary by either case button silkscreening, button population, or the logo placed on the back cover.

If there are any questions regarding the application or testing performed, please contact us at the above address or call (734) 483-4211, or e-mail liepa@umich.edu.

Sincerely,

Valdis V. Liepa
The University of Michigan Radiation Laboratory



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Ann Arbor, Michigan 48109-2122 USA
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Attn.:Federal Communications Commission
Equipment Approval Services
P.O. Box 358315
Pittsburgh, PA 15251-5315
Re: Certification for Continental Automotive Systems US Inc. M3N-97395900
FCC ID: M3N-97395900

Please find enclosed application materials for certification of Continental Automotive Systems US Inc. M3N-97395900. We tested it and found it to comply with CFR Title 47, Part 15.231.

Current Variants:

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